

TITLE: METHOD OF CLEANING SEMICONDUCTOR SURFACES
INVENTOR'S NAME: Paul A. Farrar
Dkt #: 1303.112US1

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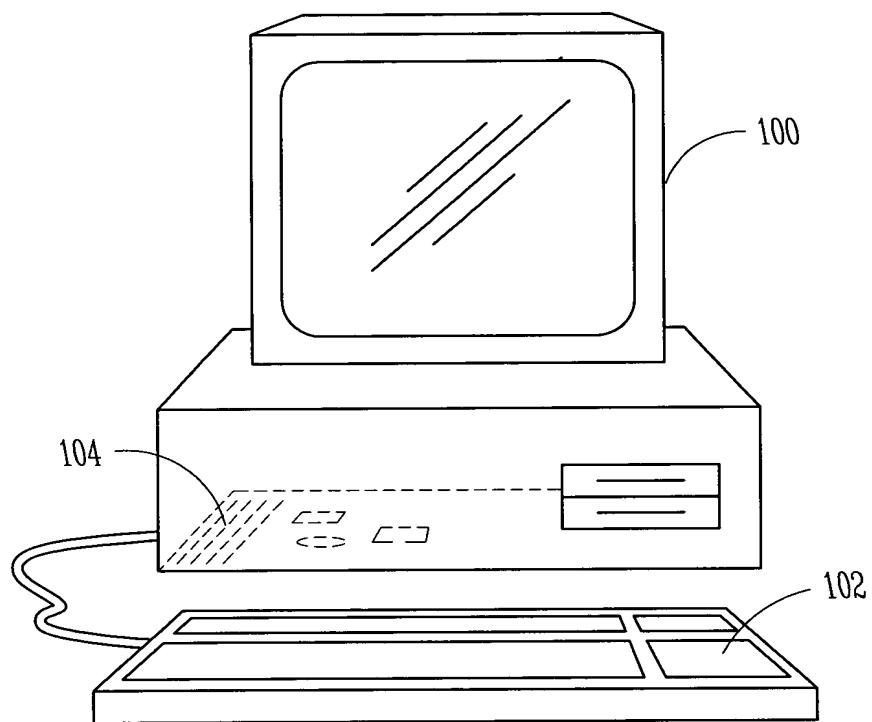


Fig. 1

Fig. 1

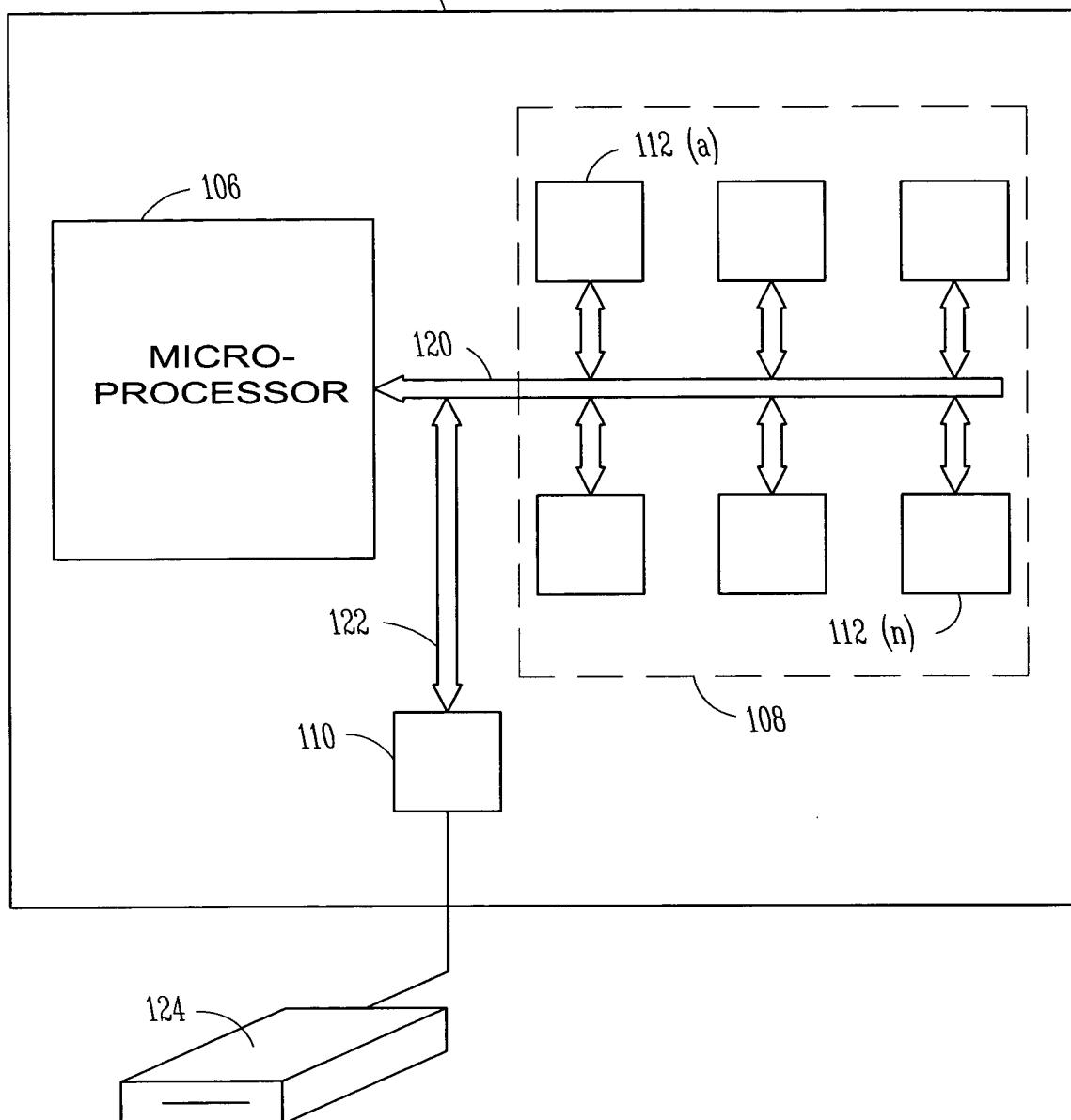


Fig. 2

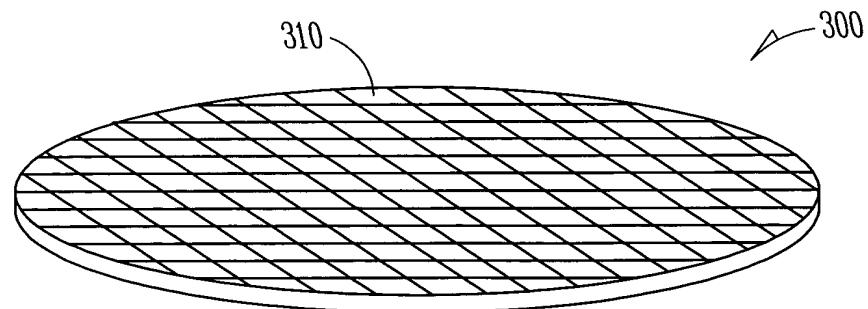


Fig. 3

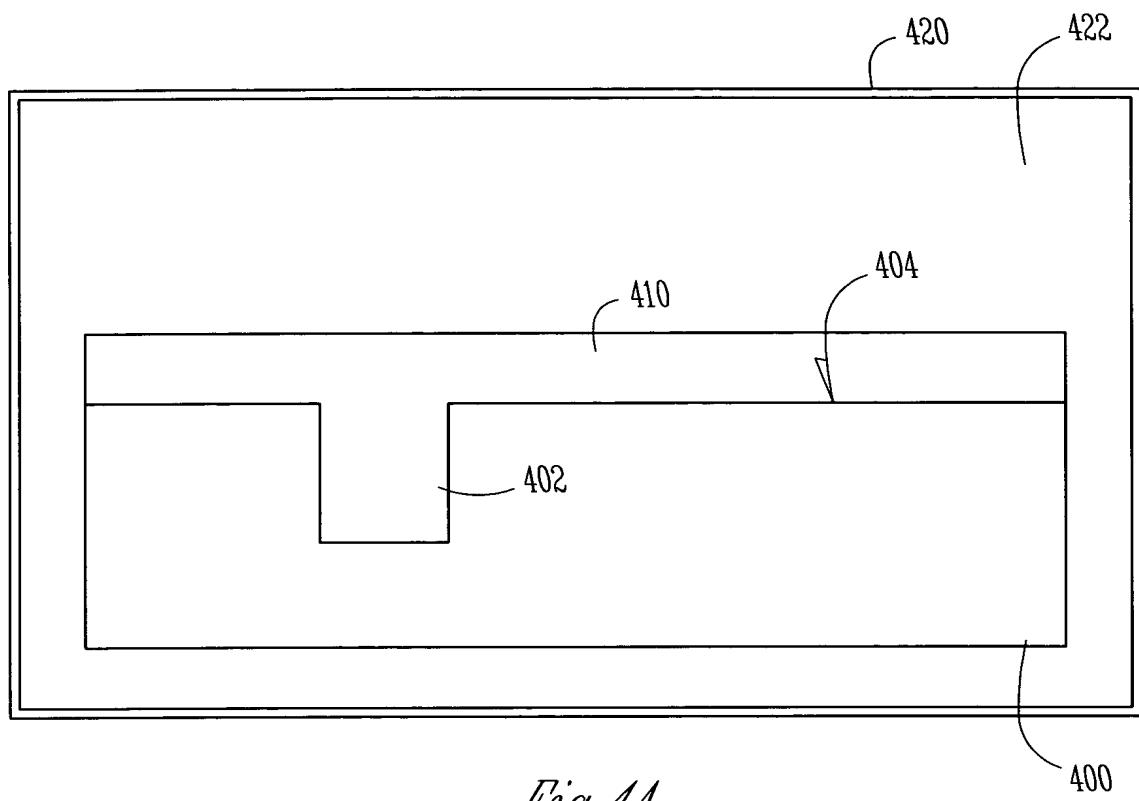


Fig. 4A

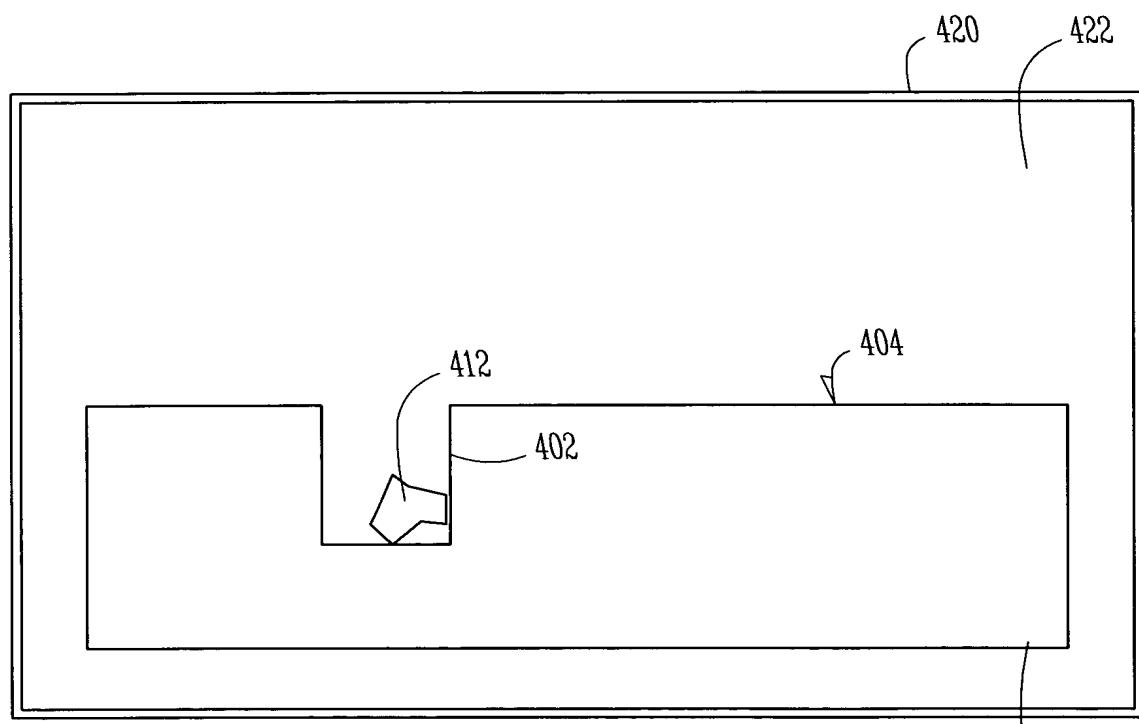


Fig. 4B

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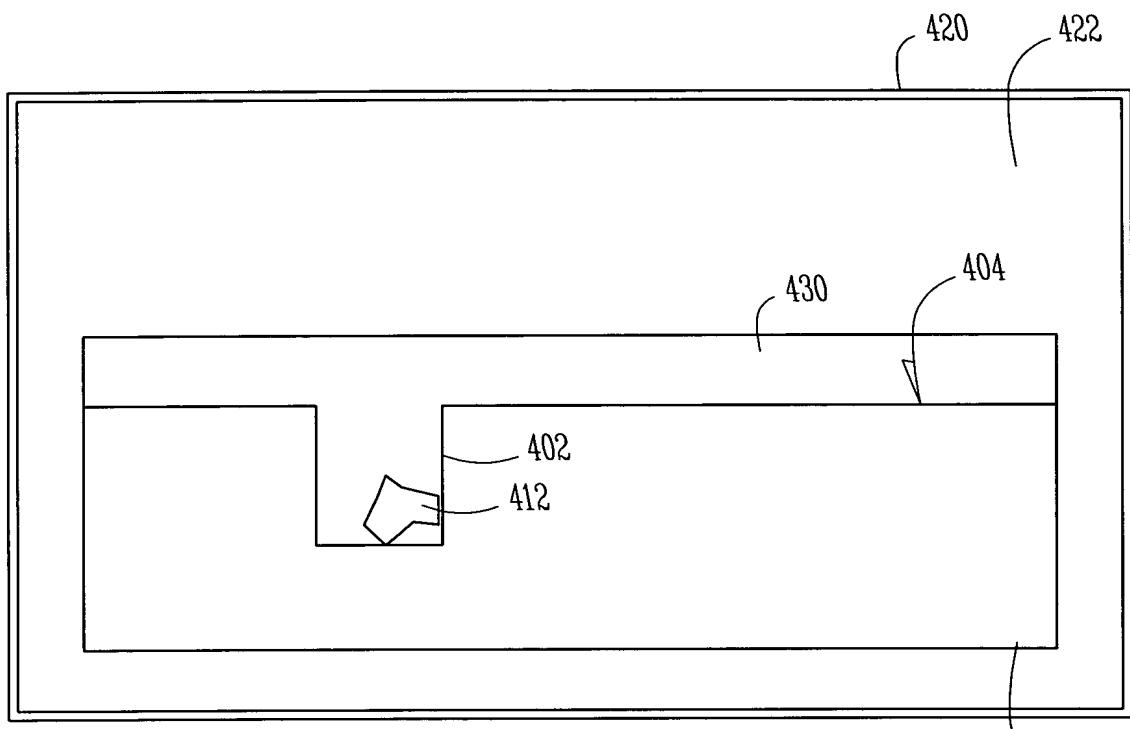


Fig. 4C

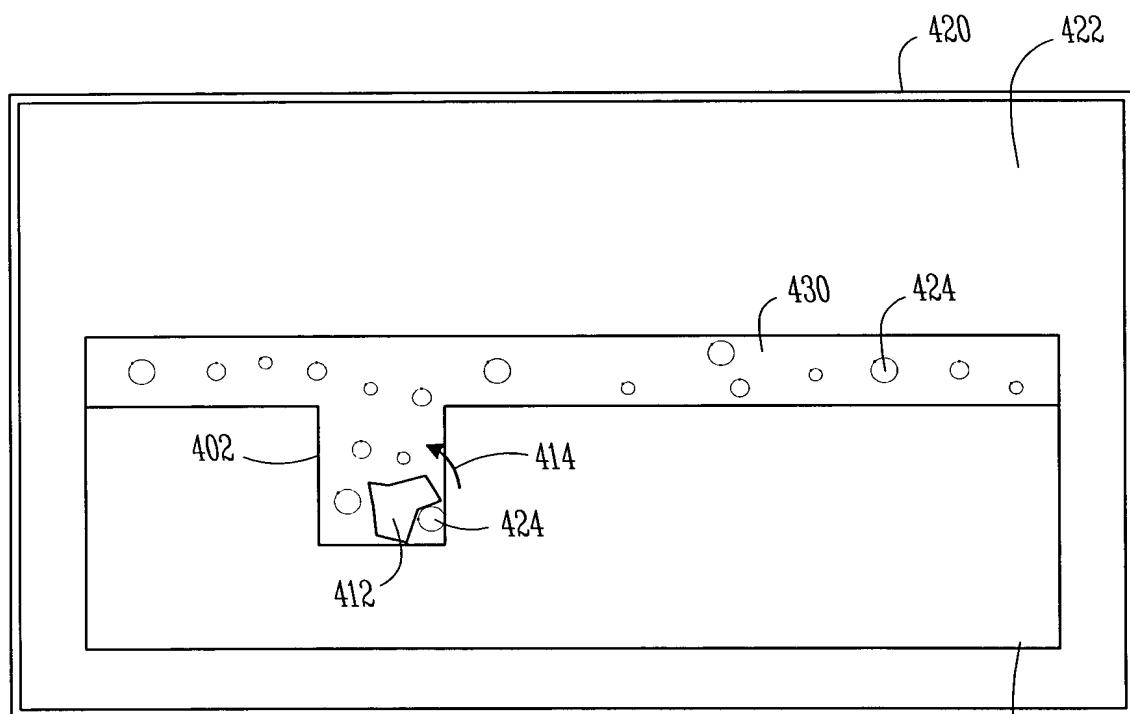


Fig. 4D

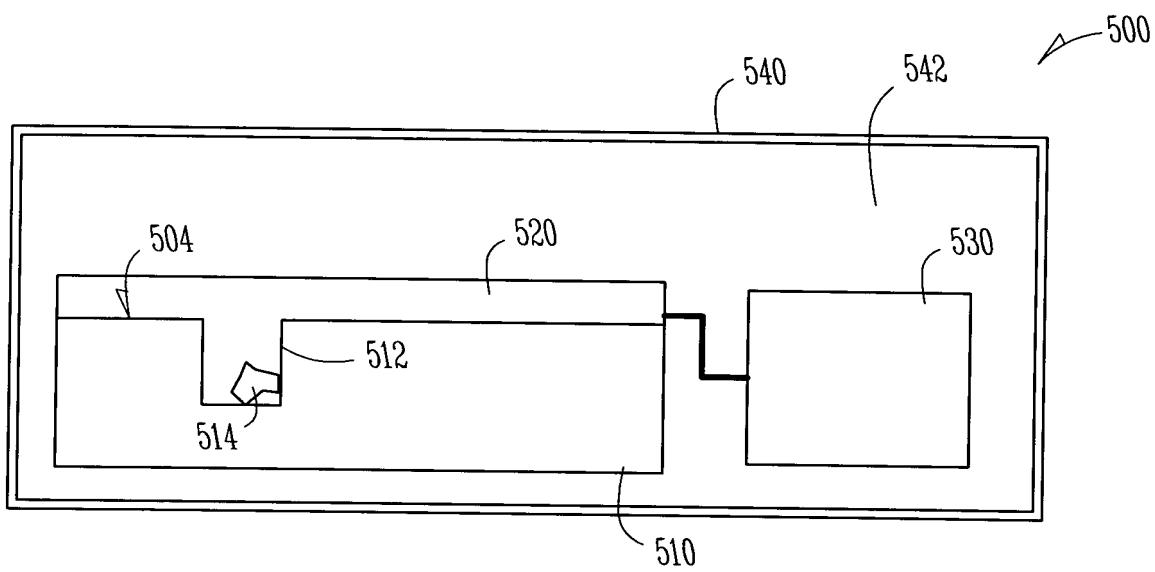


Fig. 5

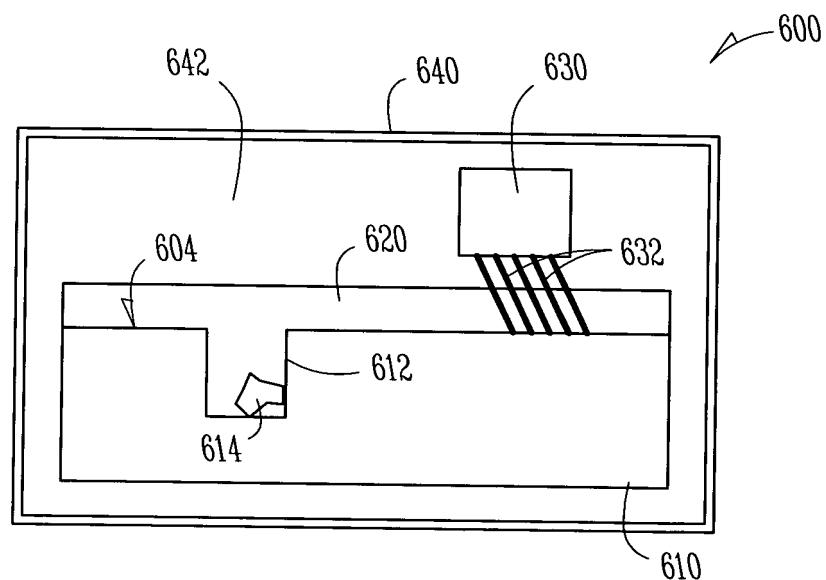


Fig. 6

